

PATENT

IN THE UNITED STATES PATENT OFFICE

In re application of:
Philip J. Ireland

Serial No.: Not Assigned

Filed: September 30, 2003 (Concurrently Herewith)

For: **CAPACITIVE COUPLING REDUCTION
USING VOID FORMATION FOR USE WITH A
SEMICONDUCTOR DEVICE**

§
§ Group Art Unit: Not Assigned
§
§ Examiner: Not Assigned
§
§ Atty. Docket: 2000-0995.01/US
§
§ Paper No. *
§
§

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Certificate of Express Mailing (37 CFR §1.10)

"Express Mail" mail number: ET658403282US

Date of Deposit: September 30, 2003

I hereby certify that this paper is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR §1.10 on the date indicated above and is addressed to the Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450.


Signature

INFORMATION DISCLOSURE STATEMENT

In compliance with the duty of disclosure under 37 CFR §1.56, Applicant respectfully requests entry of this Information Disclosure Statement, and that the references listed on the attached Form PTO-1449 be considered by the Examiner and made of record. As the references consist only of patent documents cumulative from the parent, copies are not enclosed.

In accordance with 37 CFR §1.97(b), this Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possible material information as defined in 37 CFR §1.56(a) exists.

The following reference is submitted for the Examiner's review:

U.S. Patent Documents

Document No.	Date	Inventor
5,965,940	10/1999	Juengling
5,981,384	11/1999	Juengling
5,998,256	12/1999	Juengling
6,121,552	09/2000	Brosnihan et al.
6,136,687	10/2000	Lee et al.
6,165,890	12/2000	Kohl et al.
6,177,329	01/2001	Pang
6,271,141	08/2001	Juengling et al.
6,376,357	04/2002	Onuma
6,399,476	06/2002	Kim et al.
6,451,669	09/2002	Torres et al.
6,589,861	07/2003	Park et al.

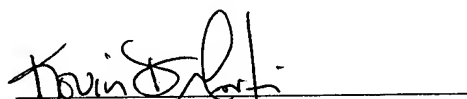
As this Information Disclosure Statement is being submitted before the mailing of a first Office Action on the merits, no fee is due. However, the Commissioner is authorized to charge any required fee to Micron Technology Inc. Deposit Account No.13-3092, Order No. 2000-0995.01/US.

If there are any matters which may be resolved or clarified through telephone interview, the Examiner is respectfully requested to contact Applicant's undersigned agent at the number indicated.

* * * *

A Form PTO-1449 is enclosed herewith.

Respectfully submitted,



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FORM: PTO-1449 (REV: 7-80)	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	Atty Docket No: 2000-0995.01/US	Serial No: Not Assigned
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Applicant: Micron Technology, Inc.	
(37 CFR 1.98(b))		Filing Date: September 30, 2003	Group: Not Assigned

(use several sheets if necessary)

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	
	AA	5,965,940	10/1999	Juengling	257	752
	AB	5,981,384	11/1999	Juengling	438	666
	AC	5,998,256	12/1999	Juengling	438	253
	AD	6,121,552	09/2000	Brosnihan et al.	174	253
	AE	6,136,687	10/2000	Lee et al.	438	624
	AF	6,165,890	12/2000	Kohl et al.	438	619
	AG	6,177,329	01/2001	Pang	438	400
	AH	6,271,141	08/2001	Juengling et al.	438	695
	AI	6,376,357	04/2002	Onuma	438	619
	AJ	6,399,476	06/2002	Kim et al.	438	619
	AK	6,451,669	09/2002	Torres et al.	438	409
	AL	6,589,861	07/2003	Park et al.	438	619

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
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	AN					<input type="checkbox"/>	<input type="checkbox"/>
	AO					<input type="checkbox"/>	<input type="checkbox"/>
	AP					<input type="checkbox"/>	<input type="checkbox"/>
	AQ					<input type="checkbox"/>	<input type="checkbox"/>
	AR					<input type="checkbox"/>	<input type="checkbox"/>

Initial

OTHER REFERENCES (including author, title, date, pertinent pages, etc.)

	AS		
	AT		
	AU		
	AV		

Examiner:	Date Considered:
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication with applicant.

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